Modelling of Statistical Low-Frequency Noise of Deep-Submicron MOSFETs

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Abstract

The low-frequency noise (LF-noise) of deep submicron MOSFETs is experimentally studied with special emphasis on yield relevant parameter scattering. A novel modeling approach is developed which includes detailed consideration of statistical effects. The model is based on device physics-based parameters which cause statistical fluctuations in LF-noise behavior of individual devices. It can easily be implemented in a compact model for use in circuit simulation tools.

Index Terms - Low-frequency noise, MOS transistors, noise modeling, semiconductor device noise, RF circuits, analog circuits.

1 - Introduction

Low-frequency noise is a performance limiting factor in many of today's CMOS analog and RF circuits. Aiming for robust circuit design, it is essential to develop a detailed understanding of the devices' noise behavior.

Recent works show that the LF-noise performance of modern small area MOS devices is dominated by Random Telegraph Signal (RTS) fluctuations [1, 2]. Their origin is the capture and subsequent emission of charge carriers at discrete trap levels near the Si–SiO₂ interface. Noise performance may strongly vary between different devices on one chip, and moreover even between different operation points of a single device. Although LF-Noise has deserved great attention, today, detailed statistical models are not available. Due to the even yield restricting effect of low

frequency noise in many applications (e.g. in wireless transceiver designs) the need to statistically model the noise behavior increases, in particular for future analog and RF products. This work is aiming for provision of a comprehensive understanding of the fluctuations of LF-Noise performance of deep submicron devices.

The paper is organized as follows: After a brief discussion concerning the basics of RTS noise, a statistical modeling approach is presented based on the physical origin of the LF-noise in section 3. There, the dependence of noise performance on device geometry and operation point is studied in detail. The model is compared to experimental data from 3 different technology nodes, $0.25\mu m$ (t_{ox}=5nm), $0.13\mu m$ (t_{ox}=2.2nm), and $0.09\mu m$ (t_{ox}=1.6nm) in section 4. Finally, in section 5, the paper is concluded.

2 RTS- and 1/f-Noise

In this paragraph the average low frequency noise of individual MOSFETs is briefly reviewed, and some important parameter for the statistical evaluations following in chapter 3 are introduced. The low frequency noise of small area devices shows Lorentzian-like spectra as shown in Fig. 1. Strong fluctuations are observed for the spectra of different devices with same geometries and from the same chip. In Fig. 2, the strong dependence of RTS noise on the bias point is shown. This behavior poses great challenges to design for high yield of minimal area low noise analog and RF circuits in advanced CMOS technologies. Deviations of orders of magnitude are observed between individual devices and at different operating points of a single device (cf. Figs. 1 and 2).

Noise spectra of today's small area devices are believed to be dominated at least for a certain frequency band by RTS from single trap states. This assumption has been experimentally confirmed by time domain RTS measurements from several groups [2, 4].

As basis for the statistical modeling, the physics behind low frequency noise phenomena are discussed here with special emphasis on their microscopic nature. Traps located in the gate oxide near the interface to the silicon capture and reemit some of the carriers responsible for the drain current flowing between source and drain of the device [8]. The impact of the variation of the charging state of these traps on drain current has a similar effect as a fluctuation of the gate voltage. Therefore, an equivalent gate voltage fluctuation is frequently used to derive a simple equation for MOS low frequency noise. In this paper, all experimental results are presented as equivalent gate voltage fluctuations.

$$I_{d} = q \cdot W \cdot \mu(y) \cdot N_{c}(y) \cdot \frac{\partial V(y)}{\partial y}$$
(1a)
(1b)

and $I_d \approx g_m(V_{g,eff}) \cdot V_{g,eff}$

Here, q is the elementary charge, W the device width, $\mu(y)$ the mobility at location y in the channel, g_m the transconductance, $N_c(y)$ the number of free carriers per infinitesimal length, $\partial V(y)/\partial y$ the local lateral electrical field in the transistor, and $V_{g,eff}$ is the effective gate-voltage, defined by the difference between gate-voltage and threshold voltage. $N_c(y)$ is given by the following equation [14]:

$$N_{c}(y) \cong \left(V_{g,eff} - V(y)\right) \cdot C_{ox}/q$$
⁽²⁾

Here, V(y) is the difference between channel potential at location y and source-voltage, C_{ox} the gate capacitance per area. Eq. (2) is normally used for transistor operating conditions in the linear mode [14], but it is also valid for transistor operating points under saturation conditions to describe the current in the channel region between source and pinch-off point. Since this is the by far most relevant region for 1/f-noise considerations it is suitable for our purposes in all cases.

For sub-V_{th} operating points, the approximation

$$V_{g,eff} = 2 \cdot n \cdot kT \frac{\ln(1 + \exp(qV'_{g,eff}/2nkT))}{1 + C_{ox} \cdot \sqrt{\frac{2\Psi_s}{q\varepsilon_{si}N_{ch}}} \cdot \exp(qV'_{g,eff}/2nkT)}$$
(3)

is used for the effective gate voltage [15]. The term kT is the thermal energy, $V'_{g,eff}$ is the effective gate voltage as applied to the terminals of the device. This equation is e.g. used in the BSIM models. In strong inversion $V'_{g,eff}$ is similar to $V_{g,eff}$. For sub- V_{th} , the formula allows a monotonic enhancement of the classical current formulation (eq. 1). A discussion of other parameters in eq. (3), which are not important in this context, is given in [15]. Eqs. (2) and (3) give us a drain current formula for deriving the standard deviation of the drain current (in other words: the current noise) due to trap influence.

The influence of the traps on the drain current is twofold. On the one hand, the occupation of a trap changes the number of free carriers in the channel, on the other hand, a charged trap state has a strong influence on the local mobility near to its position due to Coulomb scattering. Current fluctuations are calculated according to [3]:

$$\frac{\delta I_d}{I_d} = \frac{\delta N_c}{N_c(y)} + \frac{\delta \mu}{\mu(y)} = \left(\frac{1}{N_c(y)} \cdot \frac{\delta N_c}{\delta N_{tr}} + \frac{1}{\mu(y)} \cdot \frac{\delta \mu}{\delta N_{tr}}\right) \cdot \delta N_{tr}$$
(4)

Here N_{tr} is the number of traps. $\delta N_c / \delta N_{tr}$ is the change in the number of free carriers versus the number of occupied traps and $\delta \mu / \delta N_{tr}$ describes the influence of a charged trap state on the mobility at location *y*.

According to [13] the first term of eq. (4) is given by the following relation:

$$\frac{\delta N_c}{\delta N_{tr}} = \frac{q^2 / kT \cdot N_c(y)}{C_{ox} + C_{it} + C_d + q^2 / kT \cdot N_c(y)}$$
(5)

 C_{it} is the interface trap capacitance and C_d the capacitance of the pn-junction.

To derive an equation for the second term in (5), $\delta \mu / \delta N_{tr}$, we have to approximate the influence of a trap on the local mobility. The mobility is given by the inverse sum of a Coulomb-scattering related term, μ_C , and an interface scattering related contribution μ_{SR} [14]:

$$\frac{1}{\mu} = \frac{1}{\mu_{SR}} + \frac{1}{\mu_C}$$
(6)

According to [16], interface scattering and coulomb-scattering are approximated by

$$\mu_{SR} = \frac{\mu_{SR,0}}{\theta \left(V_{g,eff} - V(y) + Q_B / C_{ox} \right)^2}$$
(7)

and

$$\mu_C = \frac{\mu_{0,C}}{\gamma \cdot N_{tr} + \beta} \tag{8}$$

respectively, with $\mu_{SR,0}$, Q_B , θ , β , γ , and $\mu_{0,C}$ being technology-dependent physics-based constants. Here, for simplicity we assume these parameters to be constant. Eqs. (6) - (8) finally result in:

$$\mu(y) \simeq \frac{\mu_0}{1 + \theta^* (V_{g,eff} - V(y))}$$
⁽⁹⁾

with μ_0 and θ^* being constants resulting from $\mu_{SR,0}$, θ , γ , and β .

On the basis of this equation the term $\delta \mu / \delta N_t$ can be easily calculated:

$$\frac{\delta\mu}{\delta N_t} = \frac{\gamma \cdot \mu^2}{\mu_{0,C}} \cdot \frac{S}{W \cdot L}$$
(10)

Here L is the length of the transistor and the scattering parameter S is introduces for modeling the influence on the mobility contribution of the surface roughness to the fluctuation. A detailed discussion is given in [17]. In a next step we calculate the impact of the change of the number of occupied traps on the drain current:

$$\frac{\delta I_d}{\delta N_{tr}} = \frac{V_{g,eff} \cdot g_m}{N_c(y) \cdot \mu(y)} \left(\frac{N_c(y) \cdot \mu(y)}{kT \cdot (C_{ox} + C_{it} + C_d)/q^2 + N_c(y)} + \frac{\gamma \cdot \mu(y)^2 \cdot N_c(y) \cdot S}{\mu_{0,C} \cdot W \cdot L} \right)$$
(11)

Using (5), (10), and (11), we obtain for the gate voltage fluctuations:

$$\frac{\delta V_g}{\delta N_{tr}} = \frac{q}{C_{ox}} \left(\frac{V_{g,eff}}{V_1 + V_{g,eff} - V(y)} + \frac{S^* \cdot V_{g,eff}}{V_2 + V_{g,eff} - V(y)} \right)$$
(12)

There, V_1 , V_2 and S^* are given by:

$$V_1 = \frac{kT}{q} \cdot \frac{C_{ox} + C_{ii}}{C_{ox}}$$
(13)

$$V_2 = \frac{1}{\theta^*} \tag{14}$$

$$S^* = -\frac{\mu_0 \cdot \gamma}{\mu_{C,0}} \cdot \frac{C_{ox}}{q} \cdot \frac{S}{\theta^*}$$
(15)

Fluctuations in the number of occupied or non-occupied trap states δN_{tr} per transistor width and frequency are related to the Fermi-Dirac distribution f(E) and the mean time constant $\tau(x, E)$ for a change in the occupation of the traps [12]:

$$\delta N_{tr}^{2} = \frac{N_{rt}(x,E)}{W \cdot L} \cdot f(E) \cdot (1 - f(E)) \cdot \frac{4 \cdot \tau(x,E)}{1 + (2\pi f \tau(x,E))^{2}}$$
(16)

Using this equation and (12), we calculate the gate voltage-related noise dS_{Vg} (= δV_g^2) per area in the channel at location *y* caused by traps with a distance *x* from the interface and the energy *E* at frequency *f*:

$$dS_{Vg}(f, x, y, E) = \frac{q^2}{C_{ox}^2 W L} \cdot \left(\frac{V_{g,eff}}{V_1 + V_{g,eff} - V(y)} + \frac{S^* \cdot V_{g,eff}}{V_2 + V_{g,eff} - V(y)} \right)^2 \cdot$$
(17)
$$N_t(E, x) \cdot f(E, x)(1 - f(E, x)) \cdot \frac{4 \cdot \tau(E, x)}{1 + (2\pi f \tau(E, x))^2} dE \, dx \, dy$$

Note that this approximation is somewhat different from previous formulations of that problem [2, 3, 12, 19] since we take into account local mobility effects at different locations within the device channel. For small area devices where the integration of trap and energy densities does not describe the behavior correctly, and we have to use a discrete summation instead of the integrants dE, dx and dy:

$$S(f) = \sum_{i=1}^{N} A_i^2 \frac{1}{f_i} \frac{1}{1 + \left(\frac{f}{f_i}\right)^2}$$
(18)

The parameter f_i defines the corner frequency of the Lorentzian spectrum of a discrete trap with index *i*:

$$f_i = 1/2 \pi \tau(E, x)$$
 (19)

In the following, statistical parameters for low-frequency noise behavior are derived on basis of (18) with A_i summarizing a number of terms from (17):

$$A_{i} = \frac{2q^{2}}{\pi C_{ox}^{2} WL} \left(\frac{V_{g,eff}}{V_{1} + V_{g,eff} - V(y_{i})} + \frac{S^{*} \cdot V_{g,eff}}{V_{2} + V_{g,eff} - V(y_{i})} \right)^{2} f(E_{i}, x_{i})(1 - f(E_{i}, x_{i})) \cdot \Delta y_{i}$$
(20)

Considering a larger number of small area devices, or the average behavior of smaller devices, the low frequency noise can be calculated using continuously distributed quantities like trap densities instead of discrete ones. The current set of equations derived here leads to models similar to those well know from the literature when applied to large area considerations (see appendix 1). A continuous formulation of the 1/f-noise behavior for all regions of operation as well as a reduction of the number of necessary fit parameters results from the model derived in this article.

3 Statistical LF-Noise Modeling

The noise of a device itself is already a statistical parameter in time, namely the standard deviation of the drain current or, alternatively, of the equivalent gate voltage. To statistically model the variations of the noise when comparing different devices we have to identify the sources of noise voltage fluctuations. As can be seen from (18), the parameters sensitive to variations are the number of traps in the active region of the device N_{tr} , the corner frequencies f_i of the different traps, as well as the amplitude A_i of the different traps. In the following, a description for the variance of each of these parameters is derived.

3.1 Standard deviation of the LF-noise

The number of traps N_{tr} is assumed to follow a Poisson distribution. If $\langle N_{tr} \rangle = N$ is the average number of traps per device in an ensemble of geometrically identical devices, the probability that N_{Tr} traps are found in a particular device is given by

$$P(N_{tr}) = \frac{N_{tr}^{-N_{tr}} - N_{e}}{N_{tr}!}$$
(21)

In order to roughly obtain a 1/f spectrum, the time constants must be approximately uniformly distributed on a logarithmic scale [10, 11]. Since the average spectrum of large MOS devices roughly shows a 1/f-behavior it is reasonable to assume a similar distribution for the time constants. Physical processes that may lead to this distribution are e.g. discussed in [11].

The probability distribution function of the trap corner frequency f_i is then given by:

$$P(f_i) = \frac{1}{\ln\left(\frac{f_{max}}{f_{min}}\right)} \cdot \frac{1}{f_i}$$
(22)

The average number of traps N is proportional to the active device area $W \times L$ and equal to

$$N = N_{\text{dec}} \ln \left(\frac{f_{\text{max}}}{f_{\text{min}}} \right) W L$$
 (23)

Here ($N_{dec} \ln 10$) is the trap density per unit area and frequency decade. The frequencies f_{min} and f_{max} delimit the frequency interval in which RTS is the origin of the LF-noise. N is then the average number of traps with corner frequencies lying between f_{min} and f_{max} .

In the next step, a noise model for the average noise of small area devices is developed based on statistical parameters of A_i .

The evaluation of the standard deviation of the average value of the noise power spectral density function S(f) is:

$$\sigma_{S(f)} = \sqrt{\frac{\langle S_f^2 \rangle - \langle S_f \rangle^2}{f}}$$
(24)

The average value of the noise power spectral density $\langle S(f) \rangle$ is evaluated by calculating the average value of (18) over A_i , f_i and N_{tr} :

$$= <<<\sum_{i=1}^{N_{tr}} A_i^2 \frac{1}{f_i} \frac{1}{1+\left(\frac{f}{f_i}\right)^2} > A_i^2 \frac{f_i}{f_i} N_{tr}$$
(25)

After some calculations discussed in more detail in appendix 2 the equation

$$\langle \mathrm{S}(\mathrm{f}) \rangle = \frac{\langle A^2 \rangle \,\mathrm{N}_{\mathrm{dec}} \,\mathrm{WL}}{\mathrm{f}} \frac{\pi}{2} \quad (26)$$

is obtained. Here $\langle A_i^2 \rangle = \langle A^2 \rangle$ is the average of the squared RTS amplitudes. This equation shows the commonly known *l/f* behavior.

Next for calculating the standard deviation, we need to calculate $\langle S(f)^2 \rangle$. We start with:

$$= < < \sum_{i=1}^{N_{tr}} \frac{A_{i}^{4}}{f_{i}^{2}} \frac{1}{\left(1 + \left(\frac{f}{f_{i}}\right)^{2}\right)^{2}} + \sum_{i \neq j}^{N_{tr}} \frac{A_{i}^{2}A_{j}^{2}}{f_{i}f_{j}} \frac{1}{1 + \left(\frac{f}{f_{i}}\right)^{2}} \frac{1}{1 + \left(\frac{f}{f_{j}}\right)^{2}} > A_{i}^{2} A_{i}^{2}$$

After some calculations which are discussed in detail in appendix 3, we finally get the standard deviation of the noise spectral density function S(f) due to scattering of the parameters A_i , f_i , and N_{tr} :

$$\sigma_{\rm S(f)}^{2} = \frac{\langle A^4 \rangle \, N_{\rm dec} \, W \, L}{2} \left(\frac{1}{f_{\rm min}^{2} + f^2} - \frac{1}{f_{\rm max}^{2} + f^2} \right)$$
(28)

Where $\langle A_i^4 \rangle = \langle A^4 \rangle$. If f_{min} becomes very small and f_{max} relatively large compared to the noise bandwidth of interest, a simplification is possible:

$$\sigma_{\rm S(f)}^{2} = \frac{\langle A^4 \rangle \, N_{\rm dec} \, W \, L}{2} \, \frac{1}{f^2} \, (29)$$

The normalized standard deviation amounts to:

$$\frac{\sigma_{\rm S(f)}}{<\rm S(f)>} = \frac{\sqrt{2}}{\pi \sqrt{\rm N_{dec} \, \rm WL}} \, \sqrt{\frac{<\rm A^4>}{<\rm A^2>2}} \qquad (30)$$

Here, the contributions due to scattering of the parameters A_i , N_{tr} , and f_i are all taken into account.

As can be seen from (29) and (30), fluctuations in the amplitude of individual RTS have a strong influence on the standard deviation of the LF-noise. Hence, the sources of fluctuations in the amplitude of individual RTS have to be investigated in more detail. This is done in the next section.

3.2 Statistical parameters of the LF-noise amplitude

The amplitude A_i of a RTS current fluctuation results from the combined effect of carrier number and mobility fluctuation as given by (4). To model the total standard deviation of the noise power spectral density it is necessary to investigate the factors that influence $\delta N_C / \delta N_C(y)$ and $\delta \mu / \mu(y)$.

We first investigate the mobility fluctuation term $\delta \mu / \mu (y)$. The mobility is impacted by carrier scattering at the location of the traps (cf. Eq. (10)). Scattering efficiency depends on inversion layer parameters, like charge carrier velocity and carrier density, and on the device geometry. A charge closer to the interface scatters carriers more effectively than one further away [5]. If the vertical distance *d* of the trap from the inversion layer is a random variable, it contributes to dispersion of the noise. To best of our knowledge analytical models for the scattering efficiency as a function of *d* have not been published so far.

A reasonable first order approach is to assume the scattering efficiency to be proportional to the intersection between the channel plane and the sphere defined by the critical trap radius r_c , as depicted in Fig. 3. The parameter r_c is assumed to be either the distance of Coulomb interaction energy which is greater than kT or the screening length L_s . Since the Coulomb potential is

$$V(r) = q/(4\pi\varepsilon r) \quad (31)$$

with r being the radial distance from the trap, the critical radius for Coulomb interaction r_{kt} is given by

$$r_{\rm kt} = \frac{q^2}{4 \pi \varepsilon \, \rm kT_e} \, (32)$$

For a two-dimensional electron gas, L_S is approximated by [4]:

$$L_{\rm s} = \sqrt{2 \frac{\epsilon \, kT}{q \, N_{\rm C}(y)}} \qquad (33)$$

The critical radius r_c is given by the minimum of L_s and r_{kt} . The radius of intersection between the channel plane and the sphere defined by the critical trap radius r_c is

$$r_i = \sqrt{r_c^2 - d^2} \qquad (34)$$

The channel area perturbed by the trap is then given by

$$A_{trap} = \pi r_i^2 = \pi (r_c^2 - d^2) \qquad (35)$$

Since r_c depends on the inversion layer carrier concentration and carrier temperature, A_{trap} may strongly depend on the bias point, especially at the drain side.

In a first order approach $\Delta \mu / \mu$ is estimated to be equal to the ratio between the perturbed area and the active channel area (*W x L*):

$$\frac{\delta\mu}{\mu(y)} = \frac{A_{\text{trap}}}{WL} = \frac{\pi r_i^2}{WL} (36)$$

It is assumed that *d* only affects the scattering efficiency of the trap, i.e., the change in mobility $\delta\mu$. There is no correlation between *d* and δN as long as $d \ll t_{ox}$. Since this condition is true for all traps with significant contributions to the device noise, this means that we can treat mobility and number fluctuations for different devices as statistically independent parameters.

The value of r_c and hence r_i depend on the bias conditions in a complex manner. Consequently, it is difficult to provide a closed expression for the variance in noise power due to mobility fluctuations. Nevertheless, at small drain bias r_c can be assumed to be constant at all channel positions in a first order approximation. If in addition all distances *d* are assumed to have equal probabilities (for $0 \le d \le r_c$), $\sigma(\delta\mu/\mu) / \langle \delta\mu/\mu \rangle$ can be calculated using eq. (36):

$$\frac{\sigma(\delta\mu/\mu)}{\langle\delta\mu/\mu\rangle} = \frac{1}{\sqrt{5}} = k_d \qquad (37)$$

The contribution of the mobility fluctuation to the total variance in noise power due to carrier scattering is particularly important at small drain voltages. Here the channel is homogeneous and variance in $\delta N_C / \delta N_C(y)$ approaches zero. Therefore, the variance due to mobility fluctuations can be modeled as a constant in a first order approximation, here.

Let us now investigate the carrier number fluctuation term $\delta N_C / \delta N_C(y)$. For this purpose the carrier density $N_C(y)$ at all positions *y* within the channel has to be known. This parameter depends on the bias condition and is a function of the local channel potential V(y) within the channel, as given by (2).

Since the number of free carriers is a function of the position *y*, also the carrier number fluctuation term $\delta N_C / \delta N_C(y)$ depends on *y*. The influence of a trap on the total current through the device depends on the local number of free carriers. Therefore, also the RTS amplitude depends on the position *y* of a trap within the channel. At low drain

voltage V_d there is almost no dependence on y, but for transistor operating points in the saturation region this effect is strongly pronounced. For small drain voltages the carrier density is approximately homogenous within the whole channel. At high V_d however, the carrier density decreases from source to drain, and $\delta N_C / \delta N_C(y)$ increases from source to the pinch-off point, where it reaches its maximum. Hence, the scattering in RTS amplitudes due to the variance of $\delta N_C / \delta N_C(y)$ increases with increasing drain bias and reaches a maximum when the device is operated in saturation.

In order to evaluate $\delta N_C / \delta N_C(y)$ at different bias points a noise efficiency term h(y) is introduced which describes the efficiency of a trap in producing noise related to number fluctuation [1]. The amplitude A_i of the trap is then directly proportional to h(y). This term depends on bias point and on the trap position, and is given by the following approximation:

$$h(y) = \frac{\partial S_{Vg}(y)}{S_{Vg}} = K_y \frac{V_{g,eff}}{kT/q \cdot (C_{ox} + C_{it})/C_{ox} + V_{gd}(y)}$$
(38)

with h(y) normalized according to:

$$\int_{0}^{L} h(y)dy = 1$$
(39)

and $V_{gd}(y)$ given by:

$$V_{gd}(y) = \begin{cases} 0 & \text{for } V_{g,eff,krit} \leq V_d \text{ and } V_{g,eff,krit} > V_{g,eff} \\ V_{g,eff} - V_{g,eff,krit} & \text{for } V_{g,eff,krit} \leq V_d \text{ and } V_{g,eff,krit} < V_{g,eff} \\ V_{g,eff} - V(y) & \text{for } V_{g,eff,krit} > V_d \end{cases}$$
(40)

with $V_{g,eff,krit} = v_s L/\mu$ and v_s being the saturation velocity. For simplicity, the potential V(y) determining the local channel carrier concentration of the MOSFET is approximated by a linear fit here:

$$V(y) = V_{g,eff} \cdot \frac{L - y}{L} + V_d \cdot \frac{y}{L}$$
(41)

In eqs. (38) - (40) we also take into account the effects arising from velocity saturation in the channel. If the vertical field at a certain position in the channel is sufficiently high for free carriers to reach saturation velocity in the inversion region, their density between this point and the drain junction remains constant. Within this region, h(y) remains constant. Finally, near drain and beyond the pinch-off point there is no attractive field for free carriers at the

interface, so that they do not interact with traps. For this reason the impact of traps in this region on trap related noise can be neglected.

Using these approximations we can calculate the dependence of A_i on bias point. To get an expression for the standard deviation we have to statistically sum up the infinitesimal small areas with different amplitudes A_i to the total noise and evaluate the resulting deviation. The resulting deviation of the noise amplitude from its average value is proportional to the integral of $h(y)^2$ from source to drain. Neglecting the non-dominant terms in this integral, the normalized deviation of noise amplitude from its average amounts to [1]:

$$\frac{\sigma(\delta N_{\rm C}/N_{\rm C})}{\langle \delta N_{\rm C}/N_{\rm C} \rangle} \approx \frac{V_{\rm D}^5}{V_{\rm Geff}^5}$$
(42)

This equation describes statistical noise deviations due to the bias point. It neither depends on technology parameters or on device geometry nor requires additional fit parameters. The scattering in RTS amplitudes due to the variance in bias point increases with drain bias and reach a maximum at saturation. For very small values of V_d the density of carriers is homogenous along the channel, and h(y)=1 within the whole channel. This condition gives us minimal variation of the noise power spectral density. As V_d increases the number of free carriers decreases with y increasing, and h(y) increases from source to drain resulting in higher variations of the noise power spectral density. With the above assumptions the term due to fluctuations in noise amplitude can finally be written as

$$\frac{\langle A^4 \rangle}{\langle A^2 \rangle^2} = 1 + \frac{V_D^5}{V_{Geff}^5} + k_d \qquad (43)$$

In the above equation, k_d describes the mobility influence and models the fluctuations in RTS amplitude that are present even at low drain bias, where $N_C(y)$ is homogenous within the whole channel and fluctuations are due to scattering of *d*. The term $V_d^5/V_{g,eff}^5$ weights the fluctuations due to the non homogeneous contribution of the traps to the low frequency noise depending on channel position at larger drain bias.

A MiniMOS [9] device simulation is performed to investigate the term $\langle A^4 \rangle / \langle A^2 \rangle^2$ under different bias conditions. In the device simulations both number and mobility fluctuations are taken into account to determine the amplitude of the drain current fluctuations δI_d . Fig. 4 shows both device simulations and the results of h(y), as a function of the trap position along the channel. Good agreement between the simplified model and the result from device simulations is found.

3.3 Standard deviation of LF-noise for different bandwidths of interest

The noise amplitude at a given frequency f and its standard deviation is an important parameter to the circuit designer. But also the noise power integrated over the circuit bandwidth, np_{BW} , and its related standard deviation are of interest in many cases. This parameter is given by the integration of eq. (18) from f_L to f_H , the lower and upper boundaries of the bandwidth of interest in a given circuit design.

$$np_{BW} = \int_{f_{L}}^{f_{H}} S(f) df \qquad (44)$$

Inserting eq. (18) in eq. (44) leads to

$$np_{BW} = \int_{f_{L}}^{f_{H}} \begin{pmatrix} N_{tr} & I_{t} \\ \sum_{i=1}^{S} & A_{i}^{2} \frac{1}{f_{i}} \frac{1}{1 + \left(\frac{f}{f_{i}}\right)^{2}} \end{pmatrix} df \quad (45)$$

After integration the average value is derived:

$$\langle np_{BW} \rangle = \langle A^2 \rangle \frac{\pi}{2} \ln(\frac{f_H}{f_L}) N_{dec} WL$$
 (46)

Finally, the statistical variance in noise power due to scattering in A_i , f_i , and N_{tr} is calculated:

$$_{5}np^{2} = \langle np_{BW}^{2} \rangle \langle np_{BW}^{2} \rangle \langle np_{BW}^{2} \rangle \langle A^{4} \rangle N_{dec} WL \left(\frac{\pi}{2} \ln(\frac{f_{H}}{f_{L}})\right)^{2}$$
 (47)

The normalized standard deviation is then:

$$\frac{\sigma_{\rm np}}{\langle {\rm np}_{\rm BW}\rangle} = \frac{1}{\sqrt{N_{\rm dec}WL}} \sqrt{\frac{\langle A^4 \rangle}{\langle A^2 \rangle^2}} \qquad (48)$$

The derivation of $\langle np_{BW} \rangle$ and σ_{np} is discussed in more detail in appendix 4. For the circuit design it is important to take into account that the standard deviation depends on number of traps, device geometry and bias point, and that the bandwidth dependence is weak. This is also discussed in greater detail in appendix 4.

3.4 Contribution of technology dependent long range statistical parameters on

the standard deviation of LF-noise

Eq. (48) assumes that there is no correlation between the standard deviation and the spacing D of two devices. However, experimental data reveal correlations between noise amplitude and transistor position, as shown in Fig. 7. The long range correlation distance is considered by a parameter S in the following. This parameter describes the variation of the low frequency noise as a function of the spacing D [7]. Modification of eq. (48) thus leads to

$$\frac{\sigma_{\rm np}^{2}}{\langle {\rm np}_{\rm BW}^{2} \rangle^{2}} = \frac{1}{N_{\rm dec} WL} \frac{\langle A^{4} \rangle}{\langle A^{2} \rangle^{2}} + S^{2} D^{2}$$
(49)

The effect of *S* is important only for large area devices at significant spacing and can be included into a compact model to simulate the long range variation effects.

4 Experimental

In this chapter the model proposed in the previous chapter is validated and compared to experimental data from three different CMOS technologies with minimum feature sizes of $0.25\mu m$ (t_{ox}=5nm, V_{dd}=2.5V), $0.13\mu m$ (t_{ox}=2.2nm, V_{dd}=1.5V), and $0.09\mu m$ (t_{ox}=1.6nm, V_{dd}=1.2V).

As seen in Fig. 1, the Lorentzian shape function of an individual RTS dominates the LF-noise characteristics. This effect can be used to distinguish between trap number related and amplitude related fluctuations. The number of traps N_{tr} is taken from the visible Lorentz spectra in the measured frequency range. From that data $1/N_{dec}$ is calculated (Table 1). The difference between those calculations and the total fluctuations give information on other sources of fluctuations discussed in the previous chapter.

For the 0.25µm technology the number of traps N_{tr} is also extracted by performing charge pumping measurements at 1 MHz. Reasonable agreement between N_{tr} evaluated from LF-noise and charge-pumping data is found confirming the proposed strategy. After extraction of N_{tr} , the term $(\langle A^4 \rangle \langle A^2 \rangle^2)^{0.5}$ is calculated (Table 1). The resulting fluctuations of the normalized noise amplitude are higher than expected for the case where only number fluctuations in N_{tr} are taken into account. This fact experimentally confirms that RTS-Amplitude fluctuations are relevant for the statistical fluctuations of the low frequency noise amplitude.

Figure 5 shows the normalized standard deviation of the low frequency noise of measured transistors as a function of device area. The area dependence predicted by eq. (48) is clearly observed here showing excellent agreement between experiment and model.

In long channel devices the average gate referred voltage noise is widely independent of bias conditions. However this is not true for noise fluctuations between different de ubmicron devices. As can be seen in Fig. 2, strong

fluctuations in noise performance do not only appear between different devices, but also for different bias points of a single device. Generally, fluctuations in noise amplitude increase for large gate and especially drain voltages (see Fig. 6) due to the increasing influence of the trap position in the channel. This is experimentally proven by the data shown in Fig. 6. At low V_d , the density of carriers is homogenous along the channel. As V_d increases the number of free carriers decreases from source to drain, and the normalized standard deviation increases in the opposite direction. Again model and experiment show good agreement without any technology dependent additional fit parameter.

The distribution of average noise power spectral density across a 200 mm wafer is shown in Figure 7. This plot gives an idea about long range process related fluctuations. Analysis of long range noise amplitude fluctuation versus distance for the 0.25µm and 0.13µm nodes leads to *SD* equal to 0.18 and 0.26 (see Eq. 49), respectively.

Conclusion

This paper discusses the impact of statistical effects on the low-frequency noise performance of CMOS devices in modern technologies. A novel low-frequency noise model including detailed physics based modeling of statistical effects is presented. Strong variations of noise performance may appear not only between devices, but also for a single device operated under different bias conditions. The noise performance is shown to depend on the number of traps, the trap position within the channel, on the depth of the trap location within the oxide, on the bias point, on device geometry, and on long-range statistical parameters. Good agreement between model and experiment is observed. The derived model can easily be implemented in a Spice like circuit simulator and is compatible with the BSIM models.

Appendix 1: Evaluation of the average noise power spectral density using trap and energy densities

This appendix contains a trap density based calculation of the MOSFET low frequency noise. Since trap densities imply a formulation which is based on mean values, the result of this calculation leads to an insight into the average noise and allows a more detailed description of the influence of device operating points. Model derivation is based on the approaches in chapter 2.

The integration of (17) in chapter 2 leads to:

$$S_{Vg}(f) = \frac{q^2 k T N_{rt}(E_f)}{4\alpha C_{ox}^2 W L^2} \cdot \frac{1}{f} \int \left(\frac{V_{g,eff}}{V_1 + V_{g,eff} - V(y)} + \frac{S^* \cdot V_{g,eff}}{V_2 + V_{g,eff} - V(y)} \right)^2 dy$$
(50)

Here α is the tunnel parameter assuming a WKB-like tunneling behavior of the traps, and calculated similar to [12]. According to [14] the incremental location *dy* is related to the incremental channel potential *dV* by:

$$dy = \frac{W \cdot \mu_0 \cdot C_{ox} \cdot V_2}{g_m \cdot V_{g,eff}} \cdot \frac{V_{g,eff} - V(y)}{V_2 + V_{g,eff} - V(y)} dV$$
(51)

Since the traps between drain and pinch-off point only provide a negligible contribution to the transistor's noise, the integration can be simplified by setting the pinch-off point as the upper integral boundary. Integration leads to a formulation of the low frequency noise caused by trap states at the oxide-semiconductor interface:

$$S_{Vg}(f) = S_{Vg}^{0} \cdot \frac{V_{g,eff}}{g_m} \left[\frac{1}{V_2} \left(\ln \left(\frac{V_1 + V_{g,eff}}{V_2 + V_{g,eff}} \frac{V_2 + V_{gd}}{V_1 + V_{gd}} \right) + \frac{V_1}{V_2 + V_{g,eff}} - \frac{V_1}{V_2 + V_{gd}} \right) + 2S^* \left(\ln \left(\frac{V_1 + V_{gd}}{V_2 + V_{gd}} \frac{V_2 + V_{g,eff}}{V_1 + V_{g,eff}} \right) + \frac{1}{V_2 + V_{gd}} - \frac{1}{V_2 + V_{g,eff}} \right) + \frac{S^{*2}}{2} \left(\frac{V_2 - 2V_{gd}}{(V_2 + V_{gd})^2} - \frac{V_2 - 2V_{g,eff}}{(V_2 + V_{g,eff})^2} \right) \right] \cdot \frac{1}{f}$$
(52)

with

$$V_{gd} = \begin{cases} 0 & \text{for } V_{g,eff} \le V_d \\ V_{g,eff} - V_d & \text{for } V_{g,eff} > V_d \end{cases}$$
(53)

and

$$S_{Vg}^{0} = \frac{q^{2} kT N_{tr}(E_{f}) \mu_{0}}{4\alpha \theta^{*} C_{ox} L^{2}}$$
(54)

The model based on eq. (52) is proven to be compatible to the compact models of the BSIM standard [18]. The model formulation is similar to the BSIM sub-threshold formulation, but is continuous over the whole range of operating points of a MOSFET. For devices operating in inversion the main difference to BSIM and other analytical low frequency noise models is the consideration of local differences in the mobility at different locations within the channel. This allows to eliminate one fit parameter compared to the BSIM approach [15, 19]. The remaining free parameters are the physics related fit parameters $N_t(E_f)$ and $\mu_{C,0} / \gamma$, which describe number and mobility fluctuation related contributions to the low frequency noise. All other parameters are standard BSIM parameters.

Appendix 2: Evaluation of the noise power spectral density <*S(f)*> on the basis of an RTS formulation

Here we discuss the derivation of the low frequency noise based on the formulation in chapter 2 which takes into account the discrete nature of the traps. The purpose here is to compare the approaches from appendix 1 and from this appendix. Moreover, the result of this calculation is needed for the evaluation of the higher statistical moments.

Starting from eq. (25) and observing that the amplitude A_i of the RTS of the *ith* trap is for a first order approximation statistically independent of the number of traps N_{tr} in a device, and also independent of the corner frequency f_i^{1} :

$$= <<\sum_{i=1}^{N_{tr}} ^2 \frac{1}{f_i} \frac{1}{1+(\frac{f}{f_i})^2} >\sum_{f_i}^{N_{tr}}$$
(55)

In the following $\langle A_i^2 \rangle$ is written as $\langle A^2 \rangle$. To evaluate the average over f_i , we use (22) for $P(f_i)$ leading to

$$\langle S(f) \rangle = \sum_{i=1}^{N_{tr}} \frac{\langle A^2 \rangle}{\ln\left(\frac{f_{max}}{f_{min}}\right)} \int_{fmin}^{fmax} \frac{1}{f_i^2} \frac{df_i}{1 + \left(\frac{f}{f_i}\right)^2}$$
(56)

After some mathematics we obtain:

$$\langle S(f) \rangle = \sum_{i=1}^{N} \frac{\langle A^2 \rangle}{\ln\left(\frac{f_{max}}{f_{min}}\right)} \frac{1}{f} \left(\arctan\left(\frac{f_{max}}{f}\right) - \arctan\left(\frac{f_{min}}{f}\right)\right)$$
(57)

Finally, we have to consider the average of N_{tr} :

¹ The amplitude and also the corner frequency depend on the trap position in the channel. This is discussed in more detail in section 3.2. However the correlation between these parameters is weak and can therefore be neglected here for simplicity.

$$\langle S(f) \rangle = \langle \sum_{i=1}^{N_{tr}} \frac{\langle A^2 \rangle}{\ln\left(\frac{f_{max}}{f_{min}}\right)} \frac{1}{f} \left(\arctan\left(\frac{f_{max}}{f}\right) - \arctan\left(\frac{f_{min}}{f}\right) \right) \rangle_{N_{tr}} (58)$$

$$= \sum_{\substack{N \text{tr} = 0}}^{\infty} \left(\sum_{i=1}^{N \text{tr}} \frac{}{\ln\left(\frac{f_{max}}{f_{min}}\right)} \frac{1}{f} \left(\arctan\left(\frac{f_{max}}{f}\right) - \arctan\left(\frac{f_{min}}{f}\right) \right) \right) P(N_{\text{tr}})$$
(59)

The summation from i=1 to $i=N_{tr}$ leads to

$$= \sum_{\substack{N_{tr}=0}}^{\infty} \left(\frac{}{\frac{f_{max}}{\ln(\frac{f_{max}}{f_{min}})}} \frac{1}{f} \left(\arctan(\frac{f_{max}}{f}) - \arctan(\frac{f_{min}}{f}) \right) N_{tr} \right) P(N_{tr})$$
(60)

Inserting eq. (21) for P(Ntr) leads to

$$=\sum_{\substack{N \text{tr}=0}}^{\infty} \left(\frac{}{\frac{f_{\text{max}}}{\ln(\frac{f_{\text{max}}}{f_{\text{min}}})}}\frac{1}{f}\left(\arctan(\frac{f_{\text{max}}}{f})-\arctan(\frac{f_{\text{min}}}{f})\right)N_{\text{tr}}\right)\frac{N_{\text{tr}}^{-N_{\text{tr}}}e^{-N}}{N_{\text{tr}}!} (61)$$

$$=\left(\frac{}{\ln\left(\frac{f_{max}}{f_{min}}\right)}\frac{1}{f}\left(\arctan\left(\frac{f_{max}}{f}\right)-\arctan\left(\frac{f_{min}}{f}\right)\right)\right)_{Vtr}^{\infty} N_{tr}\frac{N e^{-N_{tr}}e^{-N_{tr}}}{N_{tr}!}$$
(62)

and finally to:

$$=\left(\frac{}{\ln\left(\frac{f_{max}}{f_{min}}\right)}\frac{1}{f}\left(\arctan\left(\frac{f_{max}}{f}\right)-\arctan\left(\frac{f_{min}}{f}\right)\right)\right)(63)$$

<S(f)> together with eq. (23) can be rewritten as:

$$\langle S(f) \rangle = \frac{\langle A^2 \rangle N_{dec} WL}{f} \left(\arctan\left(\frac{f_{max}}{f}\right) - \arctan\left(\frac{f_{min}}{f}\right) \right)$$
(64)

If f_{min} is much smaller than the lower frequency at which the 1/f noise is of practical interest, and if f_{max} is much higher than the frequency at which the thermal noise supersedes 1/f noise, this results in

$$= \frac{N_{dec}WL}{f}\frac{\pi}{2}$$
 (65)

Note that a proportionality to 1/WL and to the average number of traps is obtained here similar to eq. (52). This is because the number of traps N_{tr} in the device is equal to $N_{dec} \times W \times L$ and because A is proportional to 1/WL. The equation above can be rewritten:

$$= \frac{k f_1(Vd, Vg) N}{WL f}$$
 (66)

Here $f_1(V_d, V_g)$ contains the bias point dependence hidden in the parameter $\langle A^2 \rangle$ in the above equation and k is a constant. Therefore the final result is equivalent to eq. (52) and therefore also to the standard low frequency noise models used for BSIM formulation [19]. The main difference is the use of a microscopic formulation of the low frequency noise which helps determining its statistical behavior. As already mentioned this derivation in contrast to appendix 1 does not detail the dependence of the low frequency noise on the operating point², but shows that the statistical approach used in chapter 3 is equivalent to the results for the average noise of large area devices. Note that this is not a shortcoming of this formulation, but it is a problem which is of minor importance here, since the fluctuations in the noise are much higher than the dependence of the average value on bias point. Moreover, the dependence of the fluctuations in amplitude on bias point is properly modeled by eq. (43).

Appendix 3: Evaluation of the standard deviation of the noise power spectral density <S(f)>

In this appendix the detailed calculation of the standard deviation of the noise power spectral density of MOSFETs is discussed.

 $\langle S(f) \rangle$ has been calculated in appendix 2. In the following $\langle S(f)^2 \rangle$ is calculated. Starting from eq. (27) and assuming that the distribution of amplitudes A_i is statistically independent of the distribution of N_{tr} and f_i (see footnote in appendix 2) and finally defining some average values: $\langle A_i^4 \rangle = \langle A^4 \rangle$ and $\langle A_i^2 | A_j^2 \rangle = \langle A^2 \rangle^2$, we may rewrite this equation as:

$$= <<\sum_{i=1}^{N_{tr}} \frac{<_{A}4>}{f_{i}^{2}} \frac{1}{\left(1 + \left(\frac{f}{f_{i}}\right)^{2}\right)^{2}} >_{f_{i}} >_{N_{tr}} + <<\sum_{i\neq j}^{N_{tr}} \frac{<_{A}2>2}{f_{i}f_{j}} \frac{1}{1 + \left(\frac{f}{f_{i}}\right)^{2}} \frac{1}{1 + \left(\frac{f}{f_{j}}\right)^{2}} >_{f_{i}} >_{N_{tr}} (67)$$

Thus, we have to find the average of two summands in eq. (67). First, we consider the first term on the right hand side:

² This dependence is hidden in the parameter $\langle A^2 \rangle$ in eq. (65)

Next, we evaluate the second term on the right hand side:

$$<\frac{\langle A^{2} \rangle}{f_{i}} \frac{1}{1 + \left(\frac{f}{f_{i}}\right)^{2}} \frac{\langle A^{2} \rangle}{f_{j}} \frac{1}{1 + \left(\frac{f}{f_{j}}\right)^{2}} > f_{i} = <\frac{\langle A^{2} \rangle}{f_{i}} \frac{1}{1 + \left(\frac{f}{f_{i}}\right)^{2}} > <\frac{\langle A^{2} \rangle}{f_{j}} \frac{1}{1 + \left(\frac{f}{f_{j}}\right)^{2}} >$$
$$= \frac{\langle A^{2} \rangle^{2} N_{dec}^{2}}{f^{2}} \left(\arctan\left(\frac{f_{max}}{f}\right) - \arctan\left(\frac{f_{min}}{f}\right)\right)^{2} (69)$$

Finally, this results in:

$$= < \sum_{i=1}^{N} \frac{}{\ln(\frac{f_{max}}{f_{min}})^{2}} \frac{1}{2} \left(\frac{1}{f_{min}^{2} + f^{2}} - \frac{1}{f_{max}^{2} + f^{2}}\right) +$$

$$N_{tr} < A^{2} > 2 N_{tr} < 2 (f_{tr} - f_{tr}) > 2$$

$$+\sum_{i\neq j}^{N_{\text{tr}}} \frac{\langle A^2 \rangle^2 N_{\text{dec}}^2}{f^2} \left(\arctan\left(\frac{f_{\text{max}}}{f}\right) - \arctan\left(\frac{f_{\text{min}}}{f}\right)\right)^2 >_{\text{Ntr}} (70)$$

This sum is rewritten as follows:

$$= < \frac{}{\ln(\frac{f_{max}}{f_{min}})} \frac{1}{2} \left(\frac{1}{f_{min}^{2} + f^{2}} - \frac{1}{f_{max}^{2} + f^{2}}\right) N_{tr} +$$

+
$$\frac{\langle A^2 \rangle^2 N_{dec}^2}{f^2} \left(\arctan\left(\frac{f_{max}}{f}\right) - \arctan\left(\frac{f_{min}}{f}\right) \right)^2 N_{tr} (N_{tr}-1) >_{N_{tr}} (71)$$

Since N_{tr} follows a Poisson distribution the average is:

$$= \frac{}{\ln(\frac{f_{max}}{f_{min}})} \frac{1}{2} \left(\frac{1}{f_{min}^{2} + f^{2}} - \frac{1}{f_{max}^{2} + f^{2}}\right) \sum_{N_{tr}=0}^{\infty} N_{tr} \frac{N_{tr} - N_{tr}}{N_{tr}!} + \frac{N_{tr} - N_{tr$$

$$+\frac{\langle A^{2} \rangle^{2} N_{dec}^{2}}{f^{2}} \left(\arctan\left(\frac{f_{max}}{f}\right) - \arctan\left(\frac{f_{min}}{f}\right)\right)^{2} \sum_{N_{tr}=0}^{\infty} N_{tr} \left(N_{tr}-1\right) \frac{N_{tr}^{-N_{tr}}e^{-N_{tr}}}{N_{tr}!}$$
(72)

For a Poisson distribution the following relations hold:

$$\sum_{N_{tr}=0}^{\infty} N_{tr} \frac{N_{tr}}{N_{tr}!} = N \quad and \sum_{N_{tr}=0}^{\infty} N_{tr}^{2} \frac{N_{tr}}{N_{tr}!} = N(N+1)$$

Therefore we finally achieve:

$$= \frac{ N_{dec} W L}{\ln(\frac{f_{max}}{f_{min}})} \frac{1}{2} \left(\frac{1}{f_{min}^{2} + f^{2}} - \frac{1}{f_{max}^{2} + f^{2}}\right) + \frac{ 2 N_{dec}^{2} (WL)^{2}}{f^{2}} \left(\arctan(\frac{f_{max}}{f}) - \arctan(\frac{f_{min}}{f})\right)^{2}$$
(73)

From this and appendix 2 we calculate the standard deviation:

$$\sigma_{S(f)}^{2} = \frac{\langle A^{4} \rangle N_{dec} W L}{2} \left(\frac{1}{f_{min}^{2} + f^{2}} - \frac{1}{f_{max}^{2} + f^{2}} \right) (74)$$

If f_{min} is much smaller than the lower frequency at which the 1/f noise is of practical interest, and if f_{max} is much higher than the frequency at which the thermal noise supersedes 1/f noise, this results in:

$$\sigma_{\rm S(f)}^2 = \frac{\langle A^4 \rangle N_{\rm dec} \ W \ L}{2} \frac{1}{f^2}$$
(75)

Finally, the normalized standard deviation amounts to:

$$\frac{\sigma_{\rm S(f)}}{\langle {\rm S(f)} \rangle} = \frac{\sqrt{2}}{\pi \sqrt{N_{\rm dec} \, {\rm WL}}} \sqrt{\frac{\langle {\rm A}^4 \rangle}{\langle {\rm A}^2 \rangle^2}} \quad (76)$$

Appendix 4: Evaluation of the noise power in the bandwidth of interest and its standard deviation

In this appendix a statistical analysis of the standard deviation of np_{BW} depending on f_L and f_H is given. Starting point will be eq. (45). The goal is to provide a compact model as a function of a minimum set of geometrical and technological parameters.

The integral in eq. (45) can be solved to:

$$np_{BW} = \sum_{i=1}^{N_{tr}} A_i^2 \operatorname{arc} tg\left(\frac{f_H}{f_i}\right) - \sum_{i=1}^{N_{tr}} A_i^2 \operatorname{arc} tg\left(\frac{f_L}{f_i}\right) = \sum_{i=1}^{N_{tr}} np_i$$
(77)

Here np_i is the contribution of a single trap with corner frequency f_i and amplitude A_i to the noise power integrated over the bandwidth. The total noise power is the sum of the contribution of all traps. Notice that even if the corner frequency f_i lies outside the bandwidth delimited by f_L and f_H it does contribute to the noise power in the bandwidth, according to the equation above.

In the following we will evaluate both average value and standard deviation of a larger ensemble of nominally identically transistors (but with different statistically distributed traps). We start with the calculation of the average based on eq. (77).

If $np_{BW}(N_{tr})$ is the noise power for the number of traps in the device to be equal to N_{tr} , and $P(N_{tr})$ is the probability that the number of traps in the device is equal to N_{tr} , then

$$< np_{BW} > = \sum_{N_{tr}=0}^{\infty} np_{BW}(N_{tr}) P(N_{tr})$$
 (78)

Here $np_{BW}(N_{tr})$ is given by eq. (45) and $P(N_{tr})$ follows a Poisson distribution. Hence,

$$< np_{BW} > \sum_{N_{tr}=0}^{\infty} \sum_{i=1}^{N_{tr}} np_{i} \frac{N_{tr}}{N_{tr}!} = \sum_{N_{tr}=0}^{\infty} (< np_{i} > N_{tr}) \frac{N_{tr}}{N_{tr}!} = \sum_{N_{tr}=0}^{\infty} (< np_{i} > N_{tr}) \frac{N_{tr}}{N_{tr}!}$$
(79)

Here $N = \langle N_{tr} \rangle$ is the average number of traps.

Let us first investigate the average of np_i given by:

$$< np_i > = \int_{f_{\min}}^{f_{\max}} np_i(A_i, f_i) P(f_i) df_i = \frac{1}{\ln\left(\frac{f_{\max}}{f_{\min}}\right)} \int_{f_{\min}}^{f_{\max}} \left(A_i^2 \operatorname{arc} \operatorname{tg}\left(\frac{f_H}{f_i}\right) - A_i^2 \operatorname{arc} \operatorname{tg}\left(\frac{f_L}{f_i}\right)\right) \frac{1}{f_i} df_i \quad (80)$$

Here f_{min} and f_{max} delimit the frequency interval in which RTS is the origin of the low-frequency noise. Note that those frequencies are different from f_L and f_{H_1} which are the boundaries of the bandwidth of interest in a given circuit design.

Assuming $\langle A_i^2 \rangle = \langle A^2 \rangle$,

$$<\mathbf{n}\mathbf{p}_{i}> = \frac{<\mathbf{A}^{2}>}{\ln\left(\frac{f_{\text{max}}}{f_{\text{min}}}\right)} \left(\int_{f_{\text{min}}}^{f_{\text{max}}} \arctan\left(\frac{f_{\text{H}}}{f_{i}}\right) \frac{1}{f_{i}} df_{i} - \int_{f_{\text{min}}}^{f_{\text{max}}} \arctan\left(\frac{f_{\text{L}}}{f_{i}}\right) \frac{1}{f_{i}} df_{i} \right) = \frac{<\mathbf{A}^{2}>}{\ln\left(\frac{f_{\text{max}}}{f_{\text{min}}}\right)} \left(\mathbf{v}(\mathbf{f}_{\text{H}}) - \mathbf{v}(\mathbf{f}_{\text{L}})\right)$$
(81)

The parameter $v(f_H) - v(f_L)$ is evaluated in the following:

With the definition of $u=f_{H}/f_i \rightarrow du = (-f_H/f_i^2)df_i \rightarrow df_i/f_i = (-f_i/f_H)du = (-1/u)du$

$$v(f_{H}) - v(f_{L}) = \int \frac{\frac{f_{H}}{f_{\min}}}{\frac{f_{H}}{f_{\max}}} \frac{\arctan u}{u} du - \int \frac{\frac{f_{L}}{f_{\min}}}{\frac{f_{L}}{f_{\max}}} \frac{\arctan u}{u} du \quad (82)$$

In this form the integral has no analytical solution, but some manipulations can be done.

Since we will always have $f_L/f_{max} < f_H/f_{max} < f_L/f_{min} < f_H/f_{min}$, $v(f_H) - v(f_L)$ becomes:

$$v(f_{H}) - v(f_{L}) = \int \frac{\frac{f_{H}}{f_{\min}}}{\frac{f_{L}}{f_{\min}}} \frac{\arctan u}{u} du - \int \frac{\frac{f_{H}}{f_{\max}}}{\frac{f_{L}}{f_{\max}}} \frac{\arctan u}{u} du \quad (83)$$

Since $(f_L/f_{max}) < 1$ and $(f_H/f_{max}) < 1$, as well as $(f_L/f_{min}) > 1$ and $(f_H/f_{min}) > 1$, *arctan(u)* can now be expanded through its Taylor series leading to

its Taylor series leading to

$$v(f_{H}) - v(f_{L}) = \int \frac{\frac{f_{H}}{f_{\min}}}{\frac{f_{L}}{f_{\min}}} \left(\frac{\pi}{2} + \sum_{n=0}^{\infty} \frac{(-1)^{n+1}}{(2n+1)u^{2n+1}} \right) \frac{du}{u} - \int \frac{\frac{f_{H}}{f_{\max}}}{\frac{f_{L}}{f_{\max}}} \sum_{n=0}^{\infty} \frac{(-1)^{n} u^{2n+1}}{(2n+1)} \frac{du}{u}$$
(84)

$$v(f_{H}) - v(f_{L}) = \frac{\pi}{2} \ln\left(\frac{f_{H}}{f_{L}}\right) + \sum_{n=0}^{\infty} \frac{(-1)^{n+1}}{2n+1} \int \frac{\frac{f_{H}}{f_{\min}}}{\frac{f_{L}}{f_{\min}}} \frac{du}{u^{2n+2}} - \sum_{n=0}^{\infty} \frac{(-1)^{n}}{2n+1} \int \frac{\frac{f_{H}}{f_{\max}}}{\frac{f_{L}}{f_{\max}}} u^{2n} du$$
(85)

$$v(f_{H}) - v(f_{L}) = \frac{\pi}{2} \ln\left(\frac{f_{H}}{f_{L}}\right) + \sum_{n=0}^{\infty} \frac{(-1)^{n}}{(2n+1)^{2}} \frac{1}{u^{2n+1}} \left| \frac{\frac{f_{H}}{f_{\min}}}{\frac{f_{L}}{f_{\min}}} - \sum_{n=0}^{\infty} \frac{(-1)^{n}}{2n+1} \frac{u^{2n+1}}{2n+1} \right| \frac{\frac{f_{H}}{f_{\max}}}{\frac{f_{L}}{f_{\max}}}$$
(86)

$$v(f_{H}) - v(f_{L}) = \frac{\pi}{2} \ln\left(\frac{f_{H}}{f_{L}}\right) + \sum_{n=0}^{\infty} \frac{(-1)^{n}}{(2n+1)^{2}} \left(\left(\frac{f_{min}}{f_{H}}\right)^{2n+1} - \left(\frac{f_{min}}{f_{L}}\right)^{2n+1} - \left(\frac{f_{H}}{f_{max}}\right)^{2n+1} + \left(\frac{f_{L}}{f_{max}}\right)^{2n+1}\right) (87)$$

If $f_{min} \ll f_L$ and $f_{max} \gg f_H$, which is usually the case, the above equation can be approximated to:

$$v(f_H) - v(f_L) = \frac{\pi}{2} \ln\left(\frac{f_H}{f_L}\right)$$
(88)

This result gives us a simpler description of eq. (80):

$$< np_{i} > = \frac{ (v(f_{H}) - v(f_{L}))}{\ln(\frac{f_{max}}{f_{min}})} = \frac{A^{2} (\pi/2) \ln(f_{H}/f_{L})}{\ln(\frac{f_{max}}{f_{min}})} (89)$$

Using eq. (89) in eq. (79) we get:

$$< np_{BW} > \sum_{N_{tr}=0}^{\infty} (N_{tr} < np_{i}) \frac{N_{tr}e^{-N_{tr}}e^{-N}}{N_{tr}!} \sum_{n_{tr}=0}^{\infty} (N_{tr} \frac{A^{2} (\pi/2) \ln(f_{H}/f_{L})}{\ln(\frac{f_{max}}{f_{min}})} \frac{N_{tr}e^{-N_{tr}}e^{-N}}{N_{tr}!} (90)$$

$$< np_{BW} > = \frac{A^{2} (\pi/2) \ln(f_{H}/f_{L})^{\infty}}{\ln(\frac{f_{max}}{f_{min}})} \sum_{N_{tr}=0}^{\infty} N_{tr} \frac{N_{tr}^{-N_{tr}} - N}{N_{tr}!} = \frac{A^{2} (\pi/2) \ln(f_{H}/f_{L})}{\ln(\frac{f_{max}}{f_{min}})} N$$
(91)

Using eq. (23) in eq. (91) we finally get

$$\langle np_{BW} \rangle = \langle A^2 \rangle \frac{\pi}{2} \ln(\frac{f_H}{f_L}) N_{dec} WL$$
 (92)

for the average noise power spectral density in the frequency band between f_L and f_{H} .

The calculation of the standard deviation of the noise power in the bandwidth of interest σ_{np} , is given by the following formula:

$$\sigma_{np} = \sqrt{\langle np_{BW}^2 \rangle - \langle np_{BW}^2 \rangle^2}$$
 (93)

 $< np_{BW} >$ is already evaluated above. So we need to evaluate $< np_{BW}^{2} >$ starting from:

$$< np_{BW}^{2} > = <<< \left(\int_{f_{L}}^{f_{H}} S(f) df \right)^{2} >_{A} >_{f}^{>} N_{tr}^{} (94)$$

$$< np_{BW}^{2} > = <<< \int_{f_{L}}^{f_{H}} \int_{f_{L}}^{f_{H}} S(f) S(f') df df' >_{A}^{>} >_{f}^{>} N_{tr}^{} (95)$$

$$< np_{BW}^{2} > = \int_{f_{L}}^{f_{H}} \int_{f_{L}}^{f_{H}} <<< S(f) S(f') >_{A}^{>} >_{f}^{>} N_{tr}^{} df df' (96)$$

Before the integral can be calculated, it is necessary to evaluate $\langle \langle S(f) S(f') \rangle \rangle$:

The first term on the right hand side in the above equation has no known analytical solution. Evaluation of the integral for the second term leads to

$$< np_{BW}^{2} > = \frac{< N_{tr}^{2} < A^{4} >}{\ln\left(\frac{f_{max}}{f_{min}}\right)} \int_{f_{L}}^{f_{H}} \int_{f_{L}}^{f_{H}} \frac{1}{(f'^{2} - f^{2})} \ln\left(\frac{f'}{f}\right) df df'' + < N_{tr}(N_{tr}^{-1}) > < A^{2} > 2\frac{\pi^{2}}{4} \ln^{2}\frac{f_{H}}{f_{L}}$$
(100)

For a Poisson distribution $\langle Ntr (Ntr - 1) \rangle = \langle Ntr \rangle^2$. Then

$$< np_{BW}^{2} > = \frac{< N_{tt}^{2} < A^{4} >}{\ln\left(\frac{f_{max}}{f_{min}}\right)} \int_{f_{L}}^{f_{H}} \int_{f_{L}}^{f_{H}} \frac{1}{(f'^{2} - f^{2})} \ln\left(\frac{f'}{f}\right) df df'' + < N_{tr}^{2} < A^{2} > 2\frac{\pi^{2}}{4} \ln^{2}\frac{f_{H}}{f_{L}}$$
(101)

This gives us the standard deviation of the noise power spectral density in the frequency band between f_L and f_{H} .

$$\sigma_{np} = \sqrt{\langle np_{BW}^2 \rangle \langle np_{BW}^2 \rangle} = \sqrt{\frac{\langle N_{tr}^2 \rangle \langle A^4 \rangle}{\ln\left(\frac{f_{max}}{f_{min}}\right)}} \int_{L}^{f_{H}} \int_{L}^{f_{H}} \frac{1}{(f'^2 - f^2)} \ln\left(\frac{f'}{f}\right) df df' (102)$$

The normalized standard deviation is:

$$\frac{\sigma_{\rm np}}{\langle {\rm np}_{\rm BW} \rangle} = \frac{1}{\sqrt{N_{\rm dec}WL}} \sqrt{\frac{\langle A^4 \rangle}{\langle A^2 \rangle^2}} \sqrt{\frac{\left(\frac{f_{\rm H}}{f_{\rm L}} + \frac{f_{\rm H}}{f_{\rm L}} + \frac{1}{(f^2 - f^2)} \ln(\frac{f'}{f}) df df'}{\ln^2 \frac{f_{\rm H}}{f_{\rm L}}}} (103)$$

For circuit simulation purposes, further simplification is mandatory. If we simplify $< np_{BW}^2 >$:

$$< np_{BW}^{2} > = \int_{f_{L}}^{f_{H}} \int_{f_{L}}^{f_{H}} < S(f) > < S(f') > df df' (104)$$

$$< np_{BW}^{2} > = \int_{f_{L}}^{f_{H}} \int_{f_{L}}^{f_{H}} < \sum_{i=1}^{N_{tr}} \frac{A_{i}^{2}}{f_{i}} \frac{1}{1 + \left(\frac{f}{f_{i}}\right)^{2}} > < \sum_{j=1}^{N_{tr}} \frac{A_{j}^{2}}{f_{j}} \frac{1}{1 + \left(\frac{f}{f_{j}}\right)^{2}} > df df' (105)$$

The evaluation of the average over f_i leads to

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$$\sum_{i=1}^{N_{\text{tr}}} \frac{A_i^2}{f_i} \frac{1}{1 + \left(\frac{f}{f_i}\right)^2} >_{fi} = \sum_{i=1}^{N_{\text{tr}}} A_i^2 \int_{f_{\min}}^{f_{\max}} \frac{1}{f_i} \frac{P(f_i) df_i}{1 + \left(\frac{f}{f_i}\right)^2} = \sum_{i=1}^{N_{\text{tr}}} \frac{A_i^2}{\ln\left(\frac{f_{\max}}{f_{\min}}\right)} \int_{f_{\min}}^{f_{\max}} \frac{1}{f_i^2} \frac{df_i}{1 + \left(\frac{f}{f_i}\right)^2} (106)$$

$$= \sum_{i=1}^{N_{tr}} \frac{A_i^2}{\ln\left(\frac{f_{max}}{f_{min}}\right)} \frac{1}{f^2} \int_{f_{min}}^{f_{max}} \frac{df_i}{1 + \left(\frac{f_i}{f}\right)^2} = \sum_{i=1}^{N_{tr}} \frac{A_i^2}{\ln\left(\frac{f_{max}}{f_{min}}\right)} \frac{1}{f} \left(\arctan\left(\frac{f_{max}}{f}\right) - \arctan\left(\frac{f_{min}}{f}\right)\right) (107)$$

After the evaluation of the average over f_j , (105) is written as

$$< np_{BW}^{2} > = \int_{f_{L}}^{f_{H}} \int_{f_{L}}^{f_{H}} < \left(\sum_{i=1}^{N_{tr}} \frac{A_{i}^{2}}{\ln\left(\frac{f_{max}}{f_{min}}\right)} \frac{1}{f} \left(\arctan\left(\frac{f_{max}}{f}\right) - \arctan\left(\frac{f_{min}}{f}\right) \right) \right).$$

$$\begin{pmatrix} N_{\text{tr}} & \frac{A_j^2}{\sum_{j=1}^{r} \frac{f_{\text{max}}}{\ln\left(\frac{f_{\text{max}}}{f_{\text{min}}}\right)}} \frac{1}{f'} \left(\arctan\left(\frac{f_{\text{max}}}{f'}\right) - \arctan\left(\frac{f_{\text{min}}}{f'}\right) \right) > df \, df' \, (108)$$

Observing that $\langle A_i^4 \rangle = \langle A^4 \rangle$ and $\langle A_i^2 A_j^2 \rangle = \langle A^2 \rangle^2$ the average over A leads to

$$< np_{BW}^{2} > = \int_{f_{L}}^{f_{H}} \int_{f_{L}}^{f_{H}} < \left(N_{tr} < A^{4} > + N_{tr}(N_{tr}^{-1}) < A^{2} > 2 \right) \left(\frac{1}{\ln\left(\frac{f_{max}}{f_{min}}\right)} \frac{1}{f} \left(\arctan\left(\frac{f_{max}}{f}\right) - \arctan\left(\frac{f_{min}}{f}\right) \right) \right).$$

$$\left(\frac{1}{\ln\left(\frac{f_{\text{max}}}{f_{\text{min}}}\right)} \frac{1}{f'} \left(\arctan\left(\frac{f_{\text{max}}}{f'}\right) - \arctan\left(\frac{f_{\text{min}}}{f'}\right)\right)\right) > Ntr \, df \, df' \, (109)$$

Noting that $< N_{tr} >^2 = < N_{tr}^2 > - < N_{tr} >$ this leads to

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$$< np_{BW}^{2} > = \int_{f_{L}}^{f_{H}} \int_{f_{L}}^{f_{H}} \left(< N_{tr}^{2} < A^{4} > + < N_{tr}^{2} < A^{2} > 2 \right) \left(\frac{1}{\ln\left(\frac{f_{max}}{f_{min}}\right)} \frac{1}{f} \left(\arctan\left(\frac{f_{max}}{f}\right) - \arctan\left(\frac{f_{min}}{f}\right) \right) \right).$$

$$\cdot \left(\frac{1}{\ln\left(\frac{f_{\text{max}}}{f_{\text{min}}}\right)} \frac{1}{f'} \left(\arctan\left(\frac{f_{\text{max}}}{f'}\right) - \arctan\left(\frac{f_{\text{min}}}{f'}\right)\right) df df'(110)$$

Now the double integral from f_L to f_H can be evaluated in the same way as in appendix 2, leading to

$$< np_{BW}^{2} > = \left(N_{tr} < A^{4} > + < N_{tr}^{2} > 2 < A^{2} > 2 \right) \left(\frac{\pi}{2} \right)^{2} \left(\frac{1}{\ln\left(\frac{f_{max}}{f_{min}}\right)} \right)^{2} \left(\ln\left(\frac{f_{H}}{f_{L}}\right) \right)^{2} (111)$$

Finally the standard deviation is calculated:

$$\sigma_{np} = \sqrt{\langle np_{BW}^2 \rangle \langle np_{BW}^2 \rangle} = \sqrt{\langle A^4 \rangle} \frac{\pi}{2} \ln(\frac{f_H}{f_L}) \sqrt{N_{dec} WL} \quad (112)$$

The normalized standard deviation is:

$$\frac{\sigma_{\rm np}}{<{\rm np}_{\rm BW}} = \frac{1}{\sqrt{N_{\rm dec}WL}} \sqrt{\frac{}{^2}} (113)$$

This simplified equation for the normalized standard deviation of the noise power in the bandwidth of interest shows the same dependency on geometry, average number of traps and RTS amplitude as the exact equation (103). The dependence on bias point is also the same in both equations. The major difference is the term including the integral in the second square root which cannot be analytically solved. Numerical analysis was performed and this term shows a weak dependency on f_L and f_H . The standard deviation slightly decreases as circuit bandwidth increases. However, the numerical analysis shows that (113) is a good approximation for (103). Eq. (113) slightly overestimates the exact value given by (103). Nevertheless, eq. (113) is appropriate for circuit simulation purposes, since it correctly describes the dependency on geometry, average number of traps and RTS amplitude.

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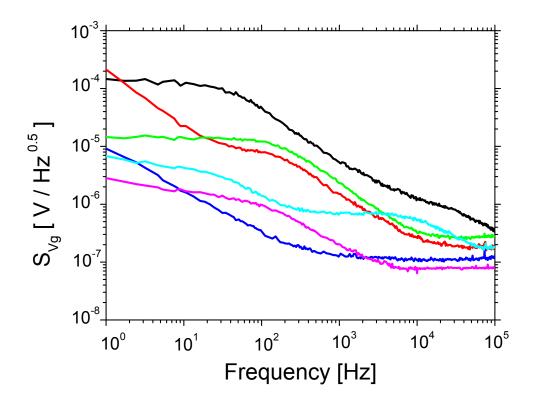


Figure 1: Gate referred voltage noise of 6 different W=0.16 μ m/L=0.13 μ m n-MOS transistors from a 0.13 μ m standard CMOS process with t_{ox}=2.2nm and V_{th} = 300 mV. Characterization in saturation at V_G = 0.55V and V_D = 1V.

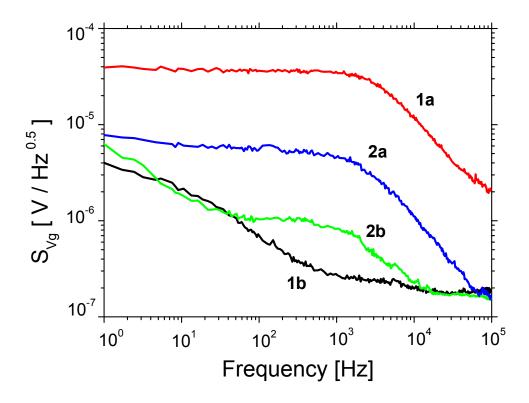


Figure 2: Gate referred voltage noise of two different W=0.16 μ m/L=0.13 μ m n-MOS transistors from a 0.13 μ m standard CMOS process with t_{ox}=2.2nm and V_{th}=300mV under different characterization conditions. Curves (1a) and (1b): first device biased at V_G=0.85V, with V_D=0.15V and V_D=1.0V, respectively; curves (2a) and (2b): second device, biased at V_D=1.0V, with V_G=0.85V and V_G=0.55V, respectively.

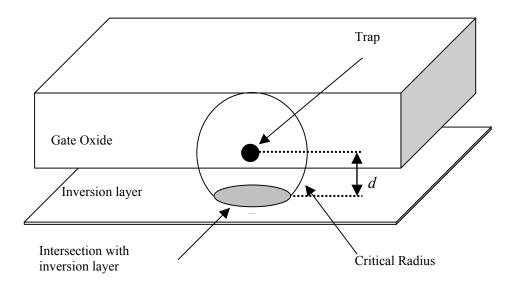


Figure 3: Schematic plot of the inversion layer of a MOS transistor disturbed by an occupied trap state. From elementary geometry considerations, the radius r_i of the intersection between the channel plane (inversion layer) and the sphere defined by the critical radius r_c is calculated according to eq. (34), for $d < r_c$. If $d \ge r_c$, it is assumed that the trap causes no scattering ($\delta \mu$ =0).

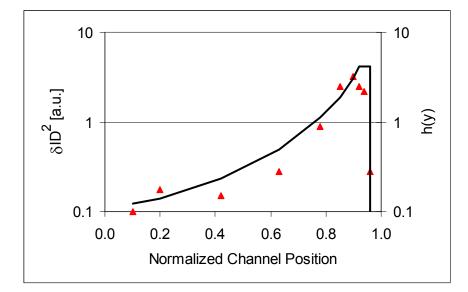


Figure 4: Triangles: Simulated contribution from traps at different channel positions (source at x=0 and drain at x=1) on the trap related noise of a MOSFET operated in saturation (left axis). Full line: efficiency term h(y) as evaluated from eq. (38) (right axis).

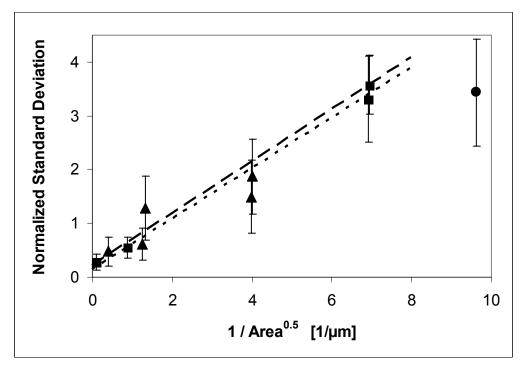


Figure 5: Normalized standard deviation of gate referred voltage noise in the bandwidth 1 Hz to 10 kHz versus area^{-0.5} for transistors biased in saturation. Error bars are 2σ -values of the measurement accuracy.

▲ 0.25µm technology node (L_{min} =0.25µm, t_{ox} =5nm). Total of 30 transistors measured.

■ 0.13µm technology node (L_{min}=0.13µm, t_{ox}=2.2nm). Total of 127 transistors measured.

• 90nm technology node (L_{min}=0.09µm, t_{ox}=1.6nm). Total of 14 transistors measured.

The dashed line shows results for the 0.13µm node calculated on the basis of eq. (49). Dotted line shows results for the 0.25µm node. (Normalized standard deviation is standard deviation of the square of gate referred voltage noise *divided by* the average of the square of gate referred voltage noise.)

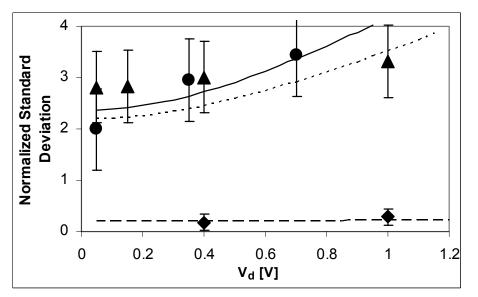


Figure 6: Normalized standard deviation of the gate referred voltage noise versus drain voltage for W/L=0.16 μ m/0.12 μ m p-MOS transistors operated at V_g - V_{th} = 0.25V (\bigstar), W/L=10 μ m/10 μ m n-MOS transistors at V_g - V_{th} = 0.25V (\bigstar) and W/L=0.12 μ m/0.09 μ m n-MOS transistors at V_g - V_{th} = 0.15V (\bullet). The full line shows the result of a calculation based on the model equations for W/L=0.12 μ m/0.09 μ m n-MOS transistors (90nm technology – all other data from 0.12 μ m technology), the dashed line for the W/L=10 μ m/10 μ m n-MOS transistors, and dotted line for the W/L=0.12 μ m/0.12 μ m p-MOS transistors.

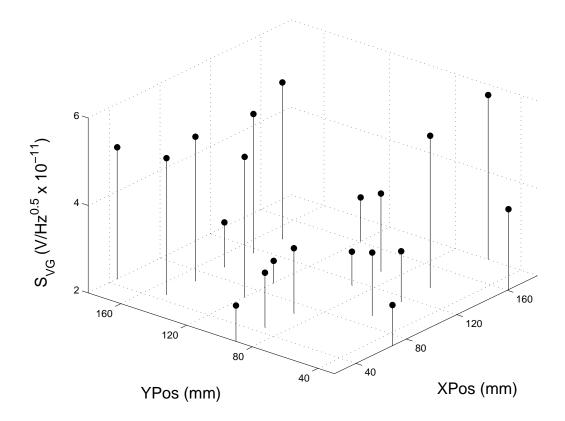


Figure 7: Gate referred voltage noise S_{VG} (bandwidth 1Hz-100kHz) of 20 n-MOSFETs from a 0.13µm standard CMOS process with t_{ox} =2.2nm, at different wafer positions. Device dimensions are W=L=10µm, characterization is performed in saturation at Vg-V_{th}=0.25V and V_d=1.0V. X and Y axis indicate die *x* and *y* position in millimeters, on a 200mm wafer. The measurements have been performed on a test waver. Therefore not all positions show target device data. These positions are not included here.

Table 1: Average number of traps per transistor $\langle N_{tr} \rangle$, $1/N_{dec}$ and $\langle A^4 \rangle / \langle A^2 \rangle^2$. Data is					
from minimum area transistors of each technology node.					
Technology	W x L	σ_{Svg}	$< N_{tr}>$	$(N_{dec}^* WL)^{-0.5}$	$(/^2)^{0.5}$
Node	(µmxµm)	Normalized			
0.25µm	0.30x0.25	1.87	9*	1.01	1.85
0.13µm	0.16x0.13	3.57	2.7^{+}	1.85	1.93
0.09µm	0.12x0.09	3.43	1.8 ⁺	2.26	1.52
* Extracted from charge pumping measurements and LF-noise data.					
+ Extracted from LF-Noise data.					